



Attorney's Docket No.: 12732-034001 US4891
AP/2822
Bhj A

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Koichiro Tanaka

Art Unit : 2822

Serial No. : 09/842,797

Examiner : Maria F. Guerrero

Filed : April 27, 2001

Title : METHOD OF FABRICATING SEMICONDUCTOR DEVICE

MAIL STOP AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF MAY 21, 2004

Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 18 of this paper.

09/22/2004 EFLURES 00000072 09842797

01 FC:1201	344.00	OP
02 FC:1202	396.00	OP